EEBM 6381 - Advanced Concepts in Microscopy

**EEBM 6381 (BMEN 6381)** Advanced Concepts in Microscopy (3 semester credit hours) Continuation of **EEBM 6380**, with emphasis on advanced approaches such as vectorial diffraction, stochastic aspects of image formation and analysis. Prerequisite: **BMEN 6380** or **EEBM 6380** or instructor consent required. (3-0) R